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Rih Data Sheet

**CONFIRMATION NO. 9922** 

Bib Data Sheet								
SERIAL NUMBER 09/876,443	FILING DATE 06/07/2001 RULE	(	CLASS 378	GROUP ART UNIT 2882		ATTORNEY DOCKET NO. 1520-006 (1426)		
Robert Allen Selzer, Waterbury, VT; Franz Ludwig Rauch, Waterbury, VT; Heinz Siegert, Williston, VT;Klaus Simon, Madison, WI; William Rudolf Frimi, New Haven, VT; Joe Baker Gagnon, Waterbury Cntr, VT; Robert Harrison Macklin, Richmond, VT;  ****CONTINUING DATA***********************************								
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/27/2001								
Foreign Priority claimed  35 USC 119 (a-d) conditions met  Verified and Acknowledged  Examiner's Signature  Initiats			STATE OR COUNTRY VT	DRAWING CL			OTAL AIMS 26	INDEPENDENT CLAIMS 4
ADDRESS 26542 JAMES MARC LEAS 37 BUTLER DRIVE S. BURLINGTON , VT 05403								
TITLE  Method of Improving x-ray lithography in the sub 100nm range to create high quality semiconductor devices								
	FEES: Authority has been given in Paper Noto charge/credit DEPOSIT ACCOUNT Nofor following:				All Fees			
FILING FEE FE					1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)			
No					1.18 Fees ( Issue )			
321					Other			
					☐ Credit			